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List of Patents and Publications for Applicant's

INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

Atty. Docket No. 10830.0097.NPUS00	Serial No. 10/646,851
Applicant Rui Lang, Jiannan Zheng, Mark K. Ku, Xiaoye Jiang, Sorin Faibish	
Filing Date: 08/22/2003	Group: 2157

U.S. Patent Documents

Exam. Init.	Ref. Des.	Document Number	Date	Name	Class	Sub Class	Filing Date of App.
MEK	A1	US 2004/0030951 A1	02/12/2004	Armangau et al.	714	6	8/6/2002
MEK	A2	US 2004/0030846 A1	02/12/2004	Armangau et al.	711	154	8/6/2002
MEK	A3	US 2004/0030727 A1	02/12/2004	Armangau et al.	707	200	8/6/2002
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Change(s) applied
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EXAMINER: /Michael Keefer/

DATE CONSIDERED: 12/15/2006

EXAMINER: INITIAL IF REFERENCE CONSIDERED, WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP609; DRAW LINE THROUGH CITATION IF NOT IN CONFORMANCE AND NOT CONSIDERED. INCLUDE COPY OF THIS FORM WITH NEXT COMMUNICATION TO APPLICANT.

INFORMATION DISCLOSURE STATEMENT — PTO-1449 (MODIFIED)